In re	U.S. Patent Application of)
AKITA) Unit 2128
Application Number: 09/987,317		ExaminerFerris III, Fred O.
Filed: November 14, 2001)
For:	SYSTEM VERIFICATION EQUIPMENT, SYSTEM VERIFICATION METHOD AND LSI MANUFACTURING METHOD USING THE SYSTEM VERIFICATION EQUIPMENT))))
Attorney Docket No. HITA.0123		<i>)</i>

Honorable Assistant Commissioner for Patents Washington, D.C. 20231

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Office Action mailed on May 11, 2005, the period of response to which is set to expire on September 11, 2005, with a one-month extension fee filed herewith. Please amend the above identified application as follows: